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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Takahiro KISHIOKA et al.

Group Art Unit: 1795

Application No.: 10/530,349

Examiner: S. LEE

Filed: April 6, 2005

Docket No.: 123418

For: COMPOSITION FOR FORMING ANTI-REFLECTIVE COATING FOR USE IN LITHOGRAPHY

INFORMATION DISCLOSURE STATEMENT

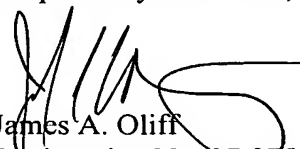
Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached.

This Information Disclosure Statement is being filed pursuant to 37 C.F.R. §1.97(i). Applicants understand that the Information Disclosure Statement will be placed in the Patent Office file, but the references will not be considered of record.

Respectfully submitted,

  
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Date: July 25, 2008

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